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APPLICATION NO.	F	ILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/773,863	10/773,863 02/09/2004		Wu-Niang Feng	J2P4002-P1670US	7216
47161	7590	11/24/2006		EXAMINER	
WU-NIAN			VANOY, TIMOTHY C		
235 CHUNG			•	ART UNIT	PAPER NUMBER
TAIWAN				1754	
				DATE MAILED: 11/24/2006	6

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)					
	10/773,863	FENG, WU-NIANG					
Office Action Summary	Examiner	Art Unit					
	Timothy C. Vanoy	1754					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).  Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).							
Status							
1) Responsive to communication(s) filed on		·					
<i>'</i> —	·—						
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims		•					
<ul> <li>4)⊠ Claim(s) <u>1-8</u> is/are pending in the application.</li> <li>4a) Of the above claim(s) is/are withdrawn from consideration.</li> </ul>							
5) Claim(s) is/are allowed.							
6)⊠ Claim(s) <u>1-8</u> is/are rejected.							
7) Claim(s) is/are objected to.	,						
8) Claim(s) are subject to restriction and/or							
Application Papers		Ť					
9) The specification is objected to by the Examiner.							
10)⊠ The drawing(s) filed on <u>09 February 2004</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).							
a) All b) Some * c) None of:							
1. Certified copies of the priority documents have been received.							
<ul><li>2. Certified copies of the priority documents have been received in Application No</li><li>3. Copies of the certified copies of the priority documents have been received in this National Stage</li></ul>							
application from the International Bureau (PCT Rule 17.2(a)).							
* See the attached detailed Office action for a list of the certified copies not received.							
Attachment(s)	_						
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 4) Interview Summary (PTO-413) Paper No(s)/Mail Date.							
3) Information Disclosure Statement(s) (PTO/SB/08)  5) Notice of Informal Patent Application							
Paper No(s)/Mail Date  S. Patent and Trademark Office	6) Other:						

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## **DETAILED ACTION**

## Claim Rejections - 35 USC § 112

The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

Claims 1-8 are rejected under 35 U.S.C. 112, first paragraph, as based on a disclosure which is not enabling. It is critical or essential to the practice of the invention for either the claims or the specification to set forth what temperatures the applicant considers "hot", but neither the claims or the specification provide a temperature range for the "hot air" mentioned in the applicants' claims. See *In re Mayhew*, 527 F.2d 1229, 188 USPQ 356 (CCPA 1976).

## Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-8 are rejected under 35 U.S.C. 102(b) as being anticipated by US 2001/0055555 A1 to Herman et al.

Claim 1 in the Herman et al. publication describes a method for removing pollutants out of a waste gas, such as a semiconductor waste gas: please also see paragraph no. 0001, comprising:

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introducing one additional gas (which may be air: please also see claim 5) into a secondary inlet;

mixing together the waste gas and the air, optionally with heating, to form a precursor reactive stream, and

introducing the precursor reactive stream into a reaction chamber and causing the pollutant-abating reaction to occur within this reaction chamber.

Please also note that the abstract also sets forth that heated air enters into the central reaction chamber.

The following references are made of record:

US 2004/0191146 A1 disclosing a method and apparatus for treating exhaust gas;

US 2004/0042948 A1 disclosing the treatment method for decomposing perfluorocompounds;

The English abstract of TW 230,240 B1 disclosing a method for increasing purification efficiency of exhaust from a semiconductor manufacturing process; and

The English abstract of KR 2005-081,035 A disclosing a method for cleaning harmful materials out of a semiconductor waste gas.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Timothy C. Vanoy whose telephone number is 571-272-8158. The examiner can normally be reached on Mon-Fri 8-4:30.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stanley Silverman, can be reached on 571-272-1358. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Trmothy C Vanos Timothy C Vanos Primary Examiner Art Unit 1754